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500.34397CV2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MIURA, et al
Serial No.: 09/977,207
Filed: October 16, 2001
For: SEMICONDUCTOR DEVICE AND PRODUCTION THEREOF
Group: 2823
Examiner: T. Dang

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Mail Stop DD
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 8, 2004

Sir:

In the matter of the above-identified application, applicants are submitting herewith a copy of the documents cited against Japanese Patent Application 7-048106 by an Office Action mailed December 16, 2003 in the attached form equivalent to form PTO/SB/08A for the Examiner's consideration.

This information disclosure statement is being submitted after the submission of a Request for Continued Examination (RCE) and is accompanied by the following certification specified in 37 CFR '1.97(e)

03/11/2004 AWONDAF1 00000057 09977207

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On information and belief, I hereby certify that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

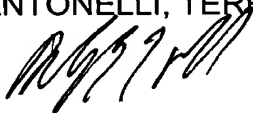
Each of the documents listed on the attached form equivalent to Form PTO-1449 has an Abstract in the English language.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus Deposit Account No. 01-2135 (500.34397CV2) please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

A handwritten signature in black ink, appearing to read 'R. Webb', is written over the printed name of the signatory.

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